

Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Docket No. 0756-2332		Serial No. Not Yet Assigned	
INFORMATION DISCLOSURE STATEMENT							
(Use several sheets if necessary)							
Applicant: Takeshi FUKADA et al.							
Filing Date: July 16, 2001 Group: 2825							
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)	
<i>gpm</i>	5,372,860	12/13/1994	Fehlner et al.	427	578		
<i>gpm</i>	4,399,015	08/16/1983	Endo et al.	204	192.26		
<i>gpm</i>	4,959,136	09/25/1990	Hatwar	204	192.15		
<i>gpm</i>	4,824,712	04/25/1989	Falleroni et al.	428	137		
<i>gpm</i>	5,163,220	11/17/1992	Zeto et al.	29	846		
<i>gpm</i>	5,094,966	03/10/1992	Yamazaki	437438	30.287		
<i>gpm</i>	5,296,653	03/22/1994	Kiyota et al.	174	250		
<i>gpm</i>	5,073,451	12/17/1991	Iida et al.	—	—		
<i>gpm</i>	4,985,312	01/15/1991	Furuya et al.	—	—		
<i>gpm</i>	5,304,518	04/19/1994	Sunahara et al.	—	—		
<i>gpm</i>	5,492,843	02/20/1996	Adachi et al.	437438	154.479		
<i>gpm</i>	5,254,208	10/19/1993	Zhang	—	—		
<i>gpm</i>	5,262,654	11/16/1993	Yamazaki	—	—		
<i>gpm</i>	5,252,140	10/12/1993	Kobayashi et al.	—	—		
<i>gpm</i>	4,100,330	07/11/1978	Donley	55428	60.6.429		
<i>gpm</i>	5,165,972	11/24/1992	Porter	55428	60.8.1.32		
<i>gpm</i>	4,116,658	09/26/1978	Sano	65	60.2.42		
<i>gpm</i>	5,480,818	01/02/1996	Matsumoto et al.	437438	40.150		
<i>gpm</i>	4,803,183	02/07/1989	Schwetz et al.	501	96.98.4		
<i>gpm</i>	5,475,264	12/12/1995	Sudo et al.	257	723		
<i>gpm</i>	5,485,019	01/16/1996	Yamazaki et al.	257	57		
Examiner <i>gpmalsau</i>		Date Considered <u>1-12-2003</u>					
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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<i>Yam</i>	5,583,369	12/10/1996	Yamazaki et al.	—	—		
<i>Yam</i>	4,435,513	03/1984	Komeya et al.	—	—		
<i>Yam</i>	4,478,785	10/1984	Huseby et al.	—	—		
<i>Yam</i>	4,963,701	10/1990	Yasumoto et al.	—	—		
<i>Yam</i>	5,674,304	10/07/1997	Fukuda et al.	—	—		
<i>Yam</i>	5,929,487	07/27/1999	Fukada et al.	—	—		
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
<i>Yam</i>	59-121876	07/14/1984	Japan	—	—	Abstract	
<i>Yam</i>	2-102150	04/13/1990	Japan	—	—	Yes	
<i>Yam</i>	58-114037	07/07/1983	Japan	—	—	Abstract	
<i>Yam</i>	64-32443	02/02/1989	Japan	—	—	Abstract	
<i>Yam</i>	1-319682	12/25/1989	Japan	—	—	Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Yam</i>	K. Etemadi, "Thermal Plasma Crystal Growth", 1989 IEEE International Conference on Plasma Science, May 22-24, 1989, pp. 115.						
<i>Yam</i>	Hickernell et al., "The Structural and Acoustic Properties of Sputtered Aluminum Nitride on Silicon", Proceedings of the Ninth IEEE International Symposium on Applications of Ferroelectrics, August 7-10, 1994, pp. 543-546.						
Examiner	<i>Yamalau</i>	Date Considered <u>1-12-2002</u>					
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